



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Isamu Kobori, et al.

Art Unit : 2822

Serial No. : 10/713,275

Examiner : Kiesha L. Rose

Filed : November 17, 2003

Title : METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF  
MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM  
TRANSISTOR

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF MAY 22, 2005

Please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.

**An abstract** is provided at page 8 of this paper.